

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Won-Jun LEE, et al.

Serial No.: 10/763,356 Examiner: Alanko, Anita Karen

Filed: January 23, 2004 Group Art Unit: 1765

Confirmation No.: 7097

For: ETCHING METHOD FOR MANUFACTURING SEMICONDUCTOR
DEVICE

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Responsive to the Office Action, Paper No. 20060606, dated June 13, 2006, please
amend the application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2
of this paper.

Remarks/Arguments begin on page 4 of this paper.